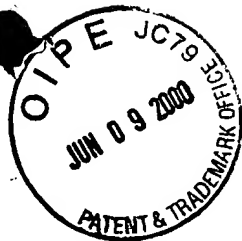


NAK1-BK00



GP 2874  
#3.6.1400

**IN THE U.S. PATENT AND TRADEMARK OFFICE**

In Re Application of:

Toshiya Fukuhisa et al.

Serial No.: 09/515,285

Filed: February 29, 2000

For: SEMICONDUCTOR LASER AND A  
MANUFACTURING METHOD FOR  
THE SAME

Examiner:

Group Art Unit 2874

Irvine, CA 92614

June 5, 2000

**INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

In an attempt to fully comply with the duty of disclosure set forth in 37 C.F.R. § 1.56 and in conformance with 37 C.F.R. §§ 1.97 and 1.98, applicants wish to bring to the attention of the U.S. Patent Office the following reference:

Electronics Letter, July 3, 1997, Vol. 33, No. 14

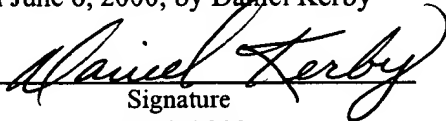
A copy of this reference and a form PTO 1449 are attached.

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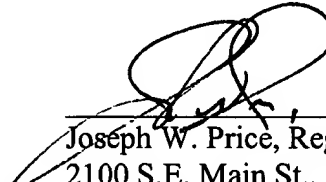
If the Examiner believes that a telephone conference would help further the prosecution of this case, he is respectfully requested to contact the undersigned attorney at the listed telephone number.

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, DC 20231, on June 6, 2000, by Daniel Kerby

  
\_\_\_\_\_  
Signature  
June 6, 2000  
\_\_\_\_\_  
Date of Signature

Very truly yours,

PRICE, GESS & UBELL

  
\_\_\_\_\_  
Joseph W. Price, Reg. No. 25,124  
2100 S.E. Main St., Ste. 250  
Irvine, CA 92614  
949/261-8433

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